## Application/Control No. Applicant(s)/Patent Under Reexamination 10/568,704 **BORTLIK ET AL. Notice of References Cited** Examiner Art Unit Page 1 of 1 Qiuwen Mi 1655

## **U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	Α	US-2002/0012714	01-2002	Olson, Bengt Krister	424/766
	В	US-			
	C	US-			
	D	US-		·	
	E	US-			
	F	US-			
	G	US-			
	Ξ	US-			
	_	US-			,
	7	US-			
	К	US-			
	L	US-			
	М	US-			

## FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	0				·	
	Р					
	Q					
	R					
	s					
	Т					

## **NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	>	
	w	
	x	·

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).) Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.

K 70 4 1 7 7